

INFORMATION DISCLOSURE STATEMENT BY APPLICANT Form PTO-1449 (Modified) (Use several sheets if necessary)				COMPLETE IF KNOWN	
				Application Number _____ Confirmation Number _____ Filing Date _____ First Named Inventor _____ Group Art Unit _____ Examiner Name _____ Attorney Docket No. 59081-8010.US01	

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 PATENT & TRADEMARK SERVICE

Sheet	1	of	1
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U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
MK	1.	6,767,840		Uehara, et al.	07/2004	
	2.	5,516,399		Balconi-Lamica, et al.	05/1996	
	3.	6,187,216		Dryer, et al.	02/2001	
	4.	4,980,017		Kaji, et al.	12/1990	
	5.	4,579,569		Sheng, et al.	04/1986	
	6.	5,891,354		Lee, et al.	04/1999	
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Examiner Initials*	Cite No.	Foreign Patent or Application			Name of Patentee or Applicant of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Office	NUMBER	Kind Code (if known)				

OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published.	T
MK	9.	Metrology for Manufacturing: Surface Measurement. [online] Michigan Technological University, undated [retrieved on 2005-06-16]. Retrieved from the Internet: <URL: http://www.mfg.mtu.edu/cyberman/quality/metrology/surface.html >	

EXAMINER 	DATE CONSIDERED <div style="text-align: center; font-size: 1.2em;">09/22/05</div>
*EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application(s).	

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Form PTO-1449 (Modified)
(Use several sheets if necessary)



COMPLETE IF KNOWN

Application Number 10/696,492
Confirmation Number 5759
Filing Date October 28, 2003
First Named Inventor Tan, et al.
Group Art Unit 1746
Examiner Name Kornakov, M.
Attorney Docket No. 59082-8010.US01

Sheet 1 of 1

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Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		2003/0096562		Kurogouchi	05/2003	
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Examiner Initials*	Cite No.	Foreign Patent or Application			Name of Patentee or Applicant of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Office	NUMBER	Kind Code (if known)				
MK		JP	50087974		Matsushita	07/1975		

OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published.	T

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